

31040 U.S. PTO  
10/084848  
02/25/02

PATENT NUMBER AND  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10084848	FILING DATE 02/25/2002	CLASS 438	SUBCLASS	GAU 2812	EXAMINER OWENS
<b>**APPLICANTS:</b> Kido Shusaku;					
<b>**CONTINUING DATA VERIFIED:</b>					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> JAPAN 58138/2001 03/02/2001					
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO MEC IPS-2364	
TITLE : Process for forming pattern and method for producing liquid crystal apparatus employing process for forming pattern					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)					

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<b>NOTICE OF ALLOWANCE MAILED</b>		Assistant Examiner	<b>CLAIMS ALLOWED</b>	
			Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		Primary Examiner	<b>DRAWING</b>	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	Application Examiner	
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